

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Toshiro YAMADA, et al.**

Serial No.: **Not Yet Assigned**
(§371 of International Application PCT/JP03/09023)

Filed: **January 14, 2005**

For: **METHOD OF DRY ETCHING, DRY ETCHING GAS AND PROCESS FOR
PRODUCING PERFLUORO-2-PENTYNE**

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: January 14, 2005

Sir:

Prior to calculation of the filing fee and examination of this application, please amend the
above-identified patent application as follows: